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TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

		F 10/36/21 (03-04)
Application Number	10/773,519	
Filing Date	February 6, 2004	
First Named Inventor	Lu, Cong	
Art Unit	2818	
Examiner Name	Tran, Long K.	
Attorney Docket Number	021653-002200US	

Date

August 15, 2005

Total Number of Pages in This Submission	6 Automey bucket Number	021653-002200US		
ENCLOSURES (Check all that apply)				
Fee Transmittal Form Fee Attached Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement	Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Address Terminal Disclaimer Request for Refund CD, Number of CD(s)	After Allowance Communication to TC Appeal Communication to Board of Appeals and Interferences Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information		
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<u>PATENT</u>

Attorney Docket No.: 021653-002200US

Client Ref. No.: I-02-120

By: Yeary Achols
Peggy Nichols

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Cong Lu

Application No.: 10/773,519

Filed: February 6, 2004

For: METHOD AND STRUCTURE FOR FABRICATING A HALFTONE MASK FOR THE MANUFACTURE OF SEMICONDUCTOR WAFERS

Customer No.: 20350

Confirmation No. 6543

Examiner:

TRAN, LONG, K

Technology Center/Art Unit: 2818

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office communication mailed 08/03/05, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.